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Dkt. 2271/75845

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shunichi SATO and Akihiro ITOH

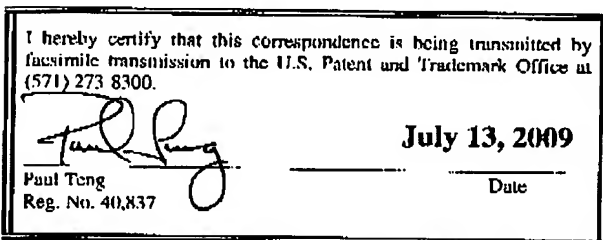
Serial No.: 10/567,809

Group Art Unit: 2828

Date Filed: June 8, 2005

Examiner: Kinam Park

For: SURFACE-EMISSION LASER DIODE AND FABRICATION PROCESS THEREOF

30 Rockefeller Plaza, 20th Floor
New York, New York 10112
Tel.: (212) 278-0400Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**AMENDMENT**

Sir:

This Amendment is submitted in response to the Office Action dated April 21, 2009 in connection with the above-identified application.

Amendments to the Claims are reflected in the **Listing of Claims** beginning on page 2.

Remarks begin on page 5 of this paper.